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Substitute for Form PTO-1449A/PTO Application Attorney Docket Number: 1987.EEM No.: 10/084.873 INFORMATION DISCLOSURE STATEMENT BY APPLICANT EXAMINER NAME: David A. Zarneke (use as many sheets as necessary) First Named Inventor: YUE XIAO et al. Filing Date: 03/01/2002 Group Art: 2812 Sheet 1 of 1 **U.S. PATENT DOCUMENTS** Pages Name of Patentee *Examiner initials **Document Number** Pub. or Applicant of Date Number - Kind Code 2 (if known) **Cited Document** MM-DD-YYYY 01/30/01 C-P Wong et al. US- 6,180,696 US- Pub. No. 2001/0034382 10/25/01 K. Sumita et al. USus. USus-US-USus-. 4 US-US-**FOREIGN PATENT DOCUMENTS** Pages Examiner initials Cite Foreign Patent Document Country Code³-Number⁴-Kind Code³ (if Pub. Date MM-DD-YYYY Name of Patentee No. 1 or Applicant of known) **Cited Document** 19/03 **EXAMINER SIGNATURE** DATE CONSIDERED Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. *EXAMINER:

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	Application Number	10/084,873			
INFORMATION DISCLOSURE	Filing Date	03/01/2002			
STATEMENT BY APPLICANT	First Named Inventor	YUE XIAO et al.			
STATEMENT DI APPLICANT	Group Art Unit	2812			
(U20 00 manu shasta oo masaasa)	Examiner Name	David A. Zarneke			
(use as many sheets as necessary)					
Sheet1 of1	Attorney Docket Number	1987.EEM			

	0	THER PRIOR ART – NON PATENT LITERATURE DOCUMENTS		
Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item, (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T	
M		SHI S. H. et al.: "Development of the Wafer Level Compressive-Flow Underfill Process and its Required Materials"; Proceedings of Elec. Components & Tech. Conf. (1999), 49 th ; Pgs. 961-966.		
OH		HARA, RYUZO: "Sealing Epoxy Resin Molding Material"; 1992, JPO & Japio; 04/09/92 JP & 424 & 727		
TOU		HIROSHI, UENO: "Curing Accelerator for Epoxy Resin"; 1995, JPO EP	0 0722	4153
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		•		
Examiner Signature	1	Was Date Considered 11/19/03		

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¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.